

**Course Schedule, group M18-621****MONDAY**

|               |   |     |       |  |                                |         |
|---------------|---|-----|-------|--|--------------------------------|---------|
| 10:15 — 11:50 | ☑ | LEC | Elect | Materials science and modern technologies in engineering | 🎓 Nevskiy R.E.                 | 📍 VNIIA |
|               | ☑ | LEC | Elect | Fundamentals of industrial safety of modern production   | 🎓 Sums koy S.I.                | 📍 I-308 |
|               | ☑ | SEM | Elect | Materials science and modern technologies in engineering | 🎓 Nevskiy R.E.                 | 📍 VNIIA |
|               | ☑ | SEM | Elect | Fundamentals of industrial safety of modern production   | 🎓 Sums koy S.I.                | 📍 I-308 |
| 11:55 — 13:30 | ■ | SEM | Elect | Materials science and modern technologies in engineering | 🎓 Nevskiy R.E.                 | 📍 VNIIA |
|               | ■ | SEM | Elect | Fundamentals of industrial safety of modern production   | 🎓 Sums koy S.I.                | 📍 I-308 |
| 14:30 — 15:15 | ■ | LEC | Elect | Mathematical modeling and computational methods          | 🎓 Shargatov V.A.               | 📍 V-117 |
| 15:20 — 17:00 | ■ | LAB | Elect | Mathematical modeling and computational methods          | 🎓 Anikeev A.A., Shargatov V.A. | 📍 V-117 |

**TUESDAY**

|               |   |     |     |                   |          |
|---------------|---|-----|-----|-------------------|----------|
| 08:30 — 10:05 | ■ | LEC | Opt | Military Training | 📍 dep.20 |
| 10:15 — 16:05 | ■ | SEM | Opt | Military Training | 📍 dep.20 |

**WEDNESDAY**

|               |   |     |  |  |                             |         |
|---------------|---|-----|--|--|-----------------------------|---------|
| 10:15 — 11:50 | ☑ | LEC |  | Thermal fields in the device engineering, thermal exposure and testing | 🎓 Antropov D.S.             | 📍 VNIIA |
|               | ☑ | SEM |  | Thermal fields in the device engineering, thermal exposure and testing | 🎓 Antropov D.S.             | 📍 VNIIA |
| 11:55 — 13:30 | ■ | SEM |  | Thermal fields in the device engineering, thermal exposure and testing | 🎓 Antropov D.S.             | 📍 VNIIA |
| 14:30 — 16:05 | ☑ | LEC |  | Construction (part 2)  | 🎓 Ushkov A.V., Yakubov R.H. | 📍 VNIIA |
|               | ☑ | SEM |  | Construction (part 2)  | 🎓 Ushkov A.V., Yakubov R.H. | 📍 VNIIA |
| 16:15 — 17:50 | ■ | SEM |  | Construction (part 2)  | 🎓 Ushkov A.V., Yakubov R.H. | 📍 VNIIA |

**THURSDAY**

|               |   |     |  |   |                |         |
|---------------|---|-----|--|---|----------------|---------|
| 12:45 — 14:20 | ☑ | LEC |  | Principles of Nuclear Technologies  | 🎓 Kadilin V.V. | 📍 V-403 |
|               | ☑ | LEC |  | Legal and International Aspects of Nonproliferation and Nuclear Materials Safety. | 🎓 Kadilin V.V. | 📍 V-403 |

**FRIDAY**

|               |   |     |       |  |                                 |         |
|---------------|---|-----|-------|--|---------------------------------|---------|
| 11:05 — 12:40 | ☑ | LEC | Elect | Microprocessor technology                          | 🎓 Benesh P.B.                   | 📍 VNIIA |
| 12:45 — 14:20 | ■ | LAB | Elect | Microprocessor technology                          | 🎓 Benesh P.B.                   | 📍 VNIIA |
| 16:15 — 17:50 | ■ | LEC |       | Management and Marketing (2019-09-06 — 2019-09-27) | 🎓 Stepanova E.B., Prohorov I.V. | 📍 B-100 |
|               | ■ | LEC |       | Management and Marketing (2019-10-04 — 2019-11-22) | 🎓 Prohorov I.V., Stepanova E.B. | 📍 B-100 |